

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hongyong Zhang Art Unit : 2814
Serial No. : 09/362,808 Examiner : Shrinivas H. Rao
Filed : July 28, 1999 Conf. No. : 7320
Title : METHOD OF FABRICATING SEMICONDUCTOR DEVICE

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

This information disclosure statement (IDS) is being filed to supplement the IDS that was filed on February 17, 2006, and cited, among other references, Netherlands Publication No. 7 314 375, cited in an office action from a foreign patent office in a counterpart foreign application. In particular, this supplemental IDS is being filed to correct the publication date of the previously-submitted Netherlands reference.

This statement is being filed after a final Office action or a Notice of Allowance, but before payment of the issue fee. Since the reference that is subject to this IDS was previously submitted, no fee is believed to be due. Please apply any charges or credits to Deposit Account No. 06 1050.

Respectfully submitted,

Date: 7/15/10



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